

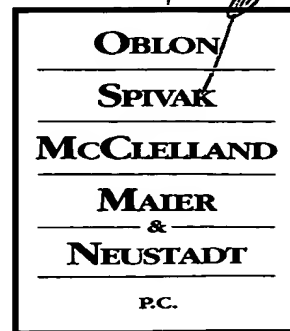


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ALEXANDRIA, VIRGINIA 22313

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"RESPONSE UNDER 37 CFR 1.116-  
EXPEDITED PROCEDURE EXAMINING  
GROUP 1754"



RE: Application Serial No.: 09/463,961

Applicants: Hiroshi IKEDA et al

Filing Date: May 25, 2000

For: PROCESS AND APPARATUS FOR TREATING  
SEMICONDUCTOR PRODUCTION EXHAUST  
GASES

Group Art Unit: 1754

Examiner: Timothy VANOY

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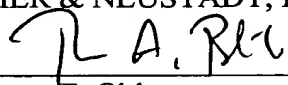
Attached hereto for filing are the following papers:

**AMENDMENT AND REQUEST FOR RECONSIDERATION  
UNDER 37 C.F.R. §1.116 (W/CITED ATTACHMENT)  
NOTICE OF APPEAL  
REQUEST FOR EXTENSION OF TIME (TWO MONTH)**

Our credit card payment form in the amount of \$730.00 is attached covering any required fees. In the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R. 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. 15-0030. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. 1.136 for the necessary extension of time. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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